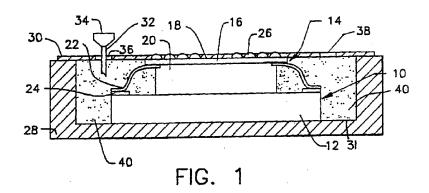
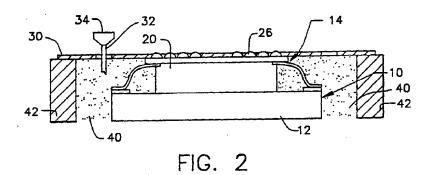
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REPORT ON THE FILING OR DETERMINATION OF AN ACTION REGARDING A PATENT OR TRADEMARK

In Compliance with 35 § 290 and/or 15 U.S.C. § 1116 you are hereby advised that a court action has been

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PLAINTIFF			DEFENDANT			
POWERTECH TECH	INOLOGY INC.		TESSERA,	INC.		
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Richard W. Wieking		Sheila Rash		March 8, 2010		





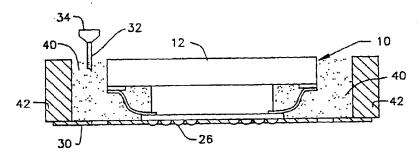


FIG. 3

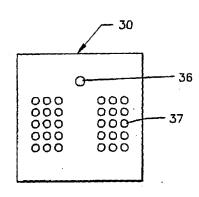
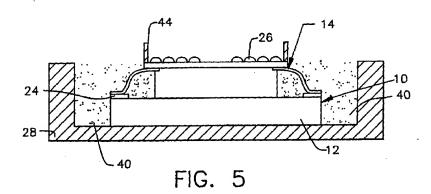
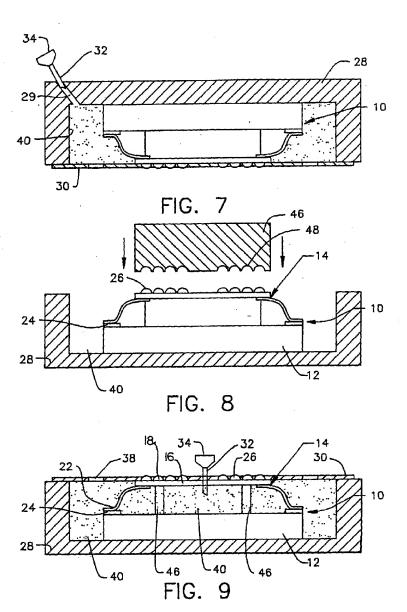


FIG. 4





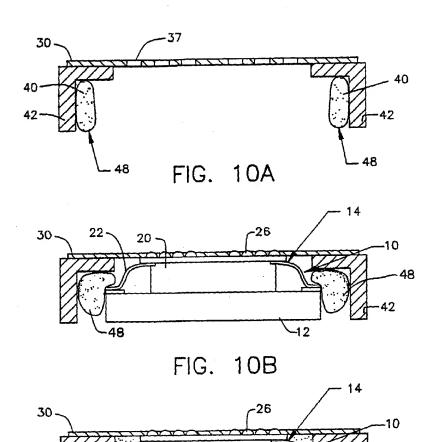


FIG. 10C

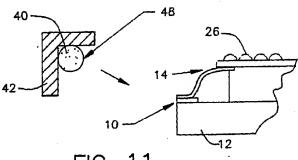


FIG. 11

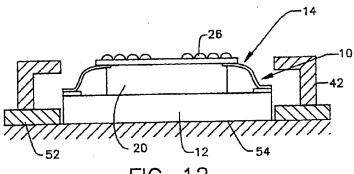


FIG. 12

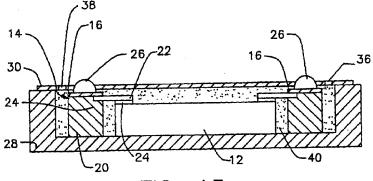


FIG. 13

METHOD OF ENCAPSULATING DIE AND CHIP CARRIER

TECHNICAL FIELD

The present invention relates generally to a method of encapsulating a semiconductor chip assembly, and more specifically to a method of encapsulating a semiconductor chip assembly within a ring or a can, while protecting the terminals on the chip carrier.

BACKGROUND OF THE INVENTION

A semiconductor chip assembly may include a chip carrier which includes a dielectric layer overlying the front 1s surface of the chip, with an array of terminals or "bumps" on the dielectric layer, and leads electrically connected to the terminals, and a semiconductor chip or "die". The bumps in the chip carrier are connected via the leads to contacts on the die. Such a chip assembly typically is used by placing it on 20 a circuit board or other circuit panel and electrically connecting the terminals on the chip carrier to the panel as by soldering.

It is often desirable to more effectively "package" a semiconductor chip assembly so that it can be handled with 25 less fear of damage to the assembly so that a heat sink can be married with the semiconductor chip or both. However, if a semiconductor chip assembly is to be so packaged for these or other purposes, the utmost care must be taken during the packaging process to avoid affecting the integrity 30 of the terminals on the chip carrier. In particular, it is important to avoid contaminating the terminals on the chip carrier with the encapsulant.

Accordingly, a method of controlling the encapsulation of a semiconductor chip assembly, with or without an elastomeric pad or layer, such that the integrity of the terminals and leads are not affected is desirable.

SUMMARY OF THE INVENTION

The present invention provides a method of controlling encapsulation of a semiconductor chip assembly, as well as providing a method of simultaneously forming elastomeric layer and controlling such encapsulation.

In accordance with one embodiment of the present 45 invention, a semiconductor chip assembly or other component having a top layer with an array of exposed terminals is encapsulated by placing it in an encapsulant barrier next to the semiconductor chip assembly such that it at least partially defines an encapsulation area, and providing a protective barrier for protecting the exposed terminals on the top layer during encapsulation. Encapsulation material is introduced into the encapsulation area, and by reason of the protective barrier, it is prevented from affecting the integrity of the exposed terminals. It is noted that the present invention contemplates the employment of the steps in any suitable order.

Preferably, the encapsulation material is introduced in a liquid form, and is subsequently hardened by any suitable means of curing the encapsulation materials. In another 60 embodiment of the present invention, the encapsulation material can be disposed in the encapsulation area as a preform, either before or after the protective barriers associated with the exposed terminals and before or after the encapsulant barrier is placed adjacent to the semiconductor 65 chip assembly. The preform of the encapsulation material can then be liquified by any suitable means so that the

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encapsulation material flows throughout the encapsulation area or a desired part of the encapsulation area.

In the preferred embodiment, the encapsulant barrier is at least a portion of a can which will form part of the encapsulation. The can is preferably made of a material which is high in thermal conductivity, such as aluminum. In another embodiment, however, the encapsulant barrier can be a ring which will remain as part of the encapsulation, but will not provide a heat sinking base. In this instance, other suitable heat sinking arrangements, or none at all, might be employed. In yet another embodiment, the encapsulant barrier can merely be a mold which will be removed after encapsulation.

It may also be desirable to provide the encapsulant barrier with means for allowing the encapsulation material to flow out of the encapsulation area and away from the exposed terminals. This might be in the form of a lowered wall, a lowered wall section, or holes provided in the walls of the can or other encapsulant barrier.

The present invention also contemplates the positioning of the semiconductor chip assembly within a can or other encapsulant barrier by means of positioning or centering means in the can.

Preferably, the protective barrier utilized in the present invention is a solder mask which provides an array of terminal holes which correspond to the array of exposed terminals on the top layer of the semiconductor chip assembly. Preferably, the terminal holes are sized to tightly receive the terminals or bumps so that the terminals are surrounded by the dielectric material of which solder mask is made. However, larger terminal holes can be provided, or, in the alternative, a large opening can be provided in the solder mask so that the entire array of terminals are exposed in such large opening.

Preferably, the solder mask is vacuum laminated to the top layer of the semiconductor chip assembly. More preferably, the solder mask is vacuum laminated not only to the top layer of the semiconductor chip assembly but also to the top side of the encapsulant barrier (the top side of the can, ring or mold walls). This arrangement, in many instances and at least with respect to the use of certain cans or molds, will fully enclose the encapsulation area, although the encapsulation area need not be so defined for the purposes of the present invention. In other words, the encapsulation area only need be partially bounded by the chip assembly, solder mask and encapsulant barrier. However, in the instance where it is fully enclosed or fully bounded by these components, it is desirable to provide a fill hole through which the encapsulation material can be injected into the encapsulation area, and in some instances, it may be preferable to utilize or provide a vent hole to prevent air from becoming entrapped in the encapsulation area.

In many instances, the encapsulation area is defined such that inversion of the encapsulant barrier, protected barrier and semiconductor assembly will facilitate the introduction of the encapsulation material.

In other embodiments of the present invention, the protective barrier can be a dam, a cap, a cover, or any other means which protects the exposed terminals on the top layer of the semiconductor chip assembly. This could also include a flexible covering member which, upon the application of pressure, will deform into engagement with the top layer around the exposed terminals to protect the same.

It should be understood that the encapsulant barrier may be provided in contact with the semiconductor chip or at a distance from the semiconductor chip, although in most cases it would be preferable to have it at a distance from the semiconductor chip. In the former instance, however, the assembly to be encapsulated may be structured such that the encapsulant barrier should be in contact with the semiconductor chip or lower section of the assembly to be encapsulated. In connection with another embodiment of the present invention, the encapsulant barrier can be spaced from the lower surface of the assembly to be encapsulated. This can be accomplished by the use of a spacer or any other

In accordance with yet another embodiment of the present invention, a semiconductor chip assembly or other component can be encapsulated by placing an encapsulant barrier adjacent the semiconductor chip assembly, such that an encapsulation area is least partially defined, and disposing a 15 preform of encapsulation material in or adjacent the encapsulation area. The preform is of a predetermined volume which is equal to or less than the encapsulation area, such that when the preform is liquified as part of the method the area to possibly affect the integrity of the exposed terminals. In this embodiment, a protective barrier is not required, although it may be employed to ensure that the encapsulation material does not contact the exposed terminals or that any of the manipulation of the assembly while practicing 25 this method will not affect the integrity of the exposed

The encapsulant can be provided as a preform which can be liquified by heating, and hardened by cooling, either directly or permitting the material to cool on its own. It is 30 also preferable that the preform be extruded or injection molded to the predetermined volume. The preform can be in the form of an elongated bead with a circular cross section, or any other suitable form or shape.

semiconductor chip assembly having a top layer with exposed terminals can be simultaneously provided with elastomeric layer and encapsulated. The matter in accordance with the present invention includes placing an encapsuch that the encapsulation barrier at least partially defines an encapsulation area, introducing an encapsulation material into the gap between the semiconductor chip and the top layer of the semiconductor chip assembly, such that the encapsulation material is disposed between the top layer and 45 the semiconductor chip, and introducing an encapsulation material into a portion of the encapsulation and providing a protective barrier for protecting the terminals on the top layer of the semiconductor chip assembly.

Preferably, the encapsulation material utilized to fill the 50 gap between the top layer and the semiconductor chip in the same encapsulation material used to fill at least a portion of the encapsulation area. In this instance, the step of introducing the encapsulating material into at least a portion of the encapsulation area may be a continuation of introducing 55 the encapsulation into at least a portion of the gap. Also preferable in this and other embodiments of the present invention, the encapsulation material is an elastomer. Still further, and in accordance with the last described method, the preferential steps of materials and components discussed 60 above in connection with other embodiments of the present invention can also be employed in connection with this method. This last described method of simultaneously forming a layer between the top layer and semiconductor chip and encapsulating the semiconductor chip assembly prefer- 65 ably includes supporting the top layer above the semiconductor chip. This supporting step may be particularly impor-

tant where a protective barrier is to be provided to protect the exposed terminals on the top layer of the semiconductor chip assembly.

BRIEF DESCRIPTION OF THE DRAWINGS

FIG. 1 is an elevational view, in partial section, illustrating a semiconductor chip assembly as it is being encapsulated within a can in accordance with one embodiment of the present invention.

FIG. 2 is an elevational view, in partial section, of a semiconductor chip assembly being encapsulated within a ring in accordance with another embodiment of the present

FIG. 3 is an elevational view, in partial section, illustrating a semiconductor chip assembly being encapsulated in an inverted position within a ring in accordance with another embodiment of the present invention.

FIG. 4 is a top plan view of a solder mask which can be encapsulation material will not flow out of the encapsulation 20 used in accordance with different embodiments of the present invention.

> FIG. 5 is an elevational view. in partial section, illustrating the encapsulation of the semiconductor chip assembly within a can in accordance with another embodiment of the present invention.

> FIG. 6 is a top plan view of a semiconductor chip assembly positioned within a can having a centering struc-

> FIG. 7 is an elevational view, in partial section, illustrating the encapsulation of a semiconductor chip assembly in an inverted position within a can in accordance with another embodiment of the present invention.

FIG. 8 is an elevational view of a semiconductor chip In still another embodiment of the present invention, a 35 assembly being prepared for encapsulation within a can, illustrating in particular the use of a terminal cap or cover in accordance with another embodiment of the present inven-

FIG. 9 is an elevational view, in partial section, illustratsulation barrier adjacent the semiconductor chip assembly, 40 ing the simultaneous formation of an elastomeric pad and the encapsulation of a semiconductor chip assembly in accordance with another embodiment of the present inven-

> FIG. 10A is an elevational view; in section, illustrating a ring, solder mask and preform arranged to facilitate the encapsulation of a semiconductor chip assembly in accordance with another embodiment of the present invention.

> FIG. 10B is an elevational view, in partial cross section. of the ring, solder mask and preform in FIG. 10A, as arranged in association with a semiconductor chip assembly in preparation for encapsulation.

FIG. 10C is an elevational view, in partial section, illustrating the liquification of the preform shown in FIG. 10B to encapsulate the semiconductor chip assembly within the

FIG. 11 is a partial elevational view, in partial section, of a preform of predetermined volume associated with a ring as it is being arranged in association with a semiconductor chip assembly for the encapsulation of such semiconductor chip assembly in accordance with another embodiment of the

FIG. 12 is an elevational view. in partial section, of a semiconductor chip assembly as it is being prepared for encapsulation within a ring, illustrating in particular the use of a spacer in accordance with another embodiment of the present invention.

FIG. 13 is an elevational view, in partial section, of a semiconductor chip as it is being prepared for encapsulation within a can, illustrating in particular the leads being directed inwardly from the elastomeric pad to the contacts.

DETAILED DESCRIPTION OF THE PREFERRED EMBODIMENTS

Referring to FIG. 1, a semiconductor chip assembly, generally designated as 10, includes a semiconductor chip 12 and a chip carrier 14. The chip carrier 14 is made up of 10 a top layer 16 (preferably a polyimide layer or the like) and an elastomeric pad 20 disposed between the top layer 16 and the semiconductor chip 12. The semiconductor chip 12 and the chip carrier 14 are electrically connected via a plurality of leads 22 which are connected to the chip 12 via contacts 15 24. The leads 22 are electrically connected to terminals 26 which protrude as "bumps" from the top surface 18 of the chip carrier 14. This assembly may, for example, be in accordance with commonly assigned U.S. Pat. Nos. 5,148, 266; 5,258,330 and 5,148,265. The arrangement of the leads 20 22 and the array of terminals 26 can be seen more clearly in the plan view of the semiconductor chip assembly of 10 shown in FIG. 6, although any arrangement of leads and terminals might form part of a given semiconductor chip assembly or other component to which the present invention 25 is applicable. It is the terminals 26 which connect the semiconductor chip assembly 10 to a printed circuit board or other substrate (not shown), and thus it is critical that the integrity of the terminals 26 must be preserved throughout testing and final assembly.

The semiconductor chip assembly 10 is, in FIG. 1, positioned for encapsulation within a can 28. The can 28, in this embodiment, will form part of the encapsulation, and prefcrably will serve as a heat sink for the semiconductor chip assembly 10. Thus, the can 28 is preferably made of a 35 positioned within a ring 42, which is essentially a wall material which is high in thermal conductivity, depending upon the specific component and its application. Aluminum is preferable in most instances. The can has a surface 31 fastened to the rear or bottom face of chip 12 by thermally conductive adhesive such as a silver-filled epoxy (not 40 shown).

FIG. 1 shows the use of a solder mask 30 which is in contact with and preferably connected to the top side of the walls of can 28 and the top surface 18 of the chip carrier 14. While the solder mask 30 could merely have a large opening 45 through which the array of terminals 26 are exposed, the solder mask 30 being connected to the perimeter of the top surface of chip carrier 14, it is preferable to provide solder mask 30 with an array of terminal holes corresponding to the array of terminals 26 on the chip carrier 14. The array of 50 terminal holes 37 is shown clearly in FIG. 4. The terminal holes 37 can be registered with the terminals 26, and are preferably of such a size that the solder mask 30 must be pressed over the terminals 26. This provides a relatively tight fit of the terminals 26 in the terminal holes of the solder 55 means. mask 30. The solder mask can be attached to the top edge of the walls of can 28 and the top surface 18 of the chip carrier 14 by a vacuum lamination method, using heat and pressure to secure the solder mask 30 in place. Any other suitable method of attachment can be used. The solder mask 30 is 60 preferably made of a dielectric material, such as a film selected from the group consisting of release film, 1/2 mil adhesive and 1/2 mil polyimide or stand-alone adhesive with release film on each side which can be vacuum laminated. Since its dielectric properties will be advantageous when the 65 terminals 26 are employed during testing or final assembly. A photosensitive polymer film may be employed to permit

formation of holes 37 by photographic processor. The preferred material for the solder mask 30 is Dupont VACREL 8100, which exhibits the desirable photosensitive and dielectric properties.

Once the semiconductor chip assembly 10 has been positioned within the can 28, and the solder mask 30 has been secured to protect the terminals 26 from the encapsulation material, the encapsulation material can be introduced into the encapsulation area, which, in most instances, about the periphery of the semiconductor chip assembly 10. This can be accomplished in a number of ways, including most preferably, the use of a needle 32 which is connected to a source 34. Thus, the needle is inserted into a fill hole 36 in the solder mask 30, there being a vent hole 38 as well, if required. The encapsulation material 40 is either injected into the encapsulation area or may, in connection with certain embodiments of the present invention, be conveyed or "pulled" from needle 32 by the capillary-like relationship of the encapsulation material 40 to the semiconductor chip assembly 10, causing the wetting of the surfaces of the semiconductor chip assembly 10. The latter method of introduction depends, of course, upon the type of encapsulation material 40 used.

The encapsulation material 40 can be of any suitable material, but preferably is a silicone resin, and in the preferred embodiment of the present invention it is a curable silicone-based encapsulant such as DC577, which is manufactured by Dow Corning Corporation of Midland. Mich. The encapsulation material 40 can be cured or partially cured in any suitable fashion, such as exposure to radiant energy, thermal energy or ultraviolet light. Several ways in which to cure materials are disclosed in the '882 application.

FIG. 2 illustrates a semiconductor chip assembly 10 as disposed about the periphery of the semiconductor chip assembly 10. In this case, a separate type of heat sink might be applied to the bottom surface of the chip 12 (as opposed to the bottom of the can 28 as shown in FIG. 1). Thus, there is an opening between the ring 42 and the chip 12 in the arrangement shown in FIG. 2. This opening might be closed for purposes of encapsulation by a mold, support surface or other substrate. In the alternative, the encapsulation material 40 might be chosen to operate on the basis of capillary action, thus wetting the surfaces and limiting and terminating flow based on surface tension (as illustrated in FIG. 10C with respect to a different embodiment of the present invention). This would prevent the encapsulation material from flowing out of the encapsulation area.

Yet another alternative would be to invert the structure shown in FIG. 2, but without a fill or vent hole in the solder mask 30, as shown in FIG. 3. Thus, the opening between the ring 42 and the chip 12 will be used in order to fill the encapsulation area with the needle 32 or any other suitable

FIG. 5 illustrates yet another embodiment by which the terminals. 26 on the chip carrier 14 can be protected from the encapsulation material 40. In this embodiment, a peripheral dam 44, which essentially consists of a wall disposed about the periphery of the top surface of chip carrier 14. This wall might be temporarily fixed to the top surface of the chip carrier 14, or, more preferably, will be a metal or plastic dam which is maintained in place on top of the chip carrier 14 by its own weight. The dam 44 will prevent the flow of the encapsulation material towards the terminals 26 on the chip carrier 14. Once the encapsulation area has been filled, the dam 44 can be removed. The dam 44 might also be in the form of a cap or cover which can be placed on the chip, carrier 14, and subsequently removed.

The embodiment shown in FIG. 8 is similar to the use of a dam 44 or a cover. It provides a shield 46 which includes an array of dimples 48 which matches the array of terminals 5 26. The shield 46 can be made of any suitable material. The concept of a shield can also be applied by utilizing a rubber shield which need not provide dimples 48, but rather will rely upon the deformability of the rubber material to surround and protect the terminals 26. Of course, in using such a rubber shield, some pressure must be applied in order to cause the rubber material to surround the terminals 26, particularly the terminals 26 around the periphery the chip carrier 14.

FIG. 7 shows yet another embodiment of a semiconductor 15 chip assembly 10 within a can 28 and employing a solder mask 30. In this embodiment, the needle 32 is inserted into a fill hole 29 in the can 28 while the entire assembly is in the inverted position. Again, as in the embodiment shown in FIG. 1, a vent hole might be necessary in the can 28 so that 20 air does not become trapped in the encapsulation area.

FIG. 9 is yet another embodiment of the present invention by which an elastomeric layer is formed between the top layer 16 of the chip carrier 14 and the chip 12 simultaneously with the encapsulation of the semiconductor chip 25 assembly 10. The chip carrier top layer 16 is initially connected to the chip by bonding leads 22 to the contacts of the chip, so that the top layer is supported about the chip surface by the leads. Such a procedure is disclosed for example in U.S. application Ser. No. 08/123,882 filed on 30 Sep. 20, 1993 by Sweis et al. ("the '882 application), now U.S. Pat. No. 5,477,611. The '882 application discloses a method of interfacing a chip carrier and a semiconductor chip, as well as providing an elastomeric layer. The disclosure of the '882 application is incorporated herein by 35 reference, although it should be recognized that the present invention is applicable in connection with methods and semiconductor chip assemblies of any type and in addition to those disclosed in the '882 application. Initially, as in the other embodiments, the solder mask 30 is attached to the top 40 side of the can 28 and the top surface 18 of the chip carrier 14. It is preferable, particularly when the solder mask 30 is to be vacuum laminated to the top surface of the chip carrier 14. that the chip carrier 14 be supported above the chip 12 by outer structures in addition to leads 22 so that the 45 integrity of the leads 22 and the connection of such leads to the chip 12 and the chip carrier 14 are not affected during lamination of the solder mask 30. Supports 46, in the form of posts, are shown in FIG. 9 between chip carrier 14 and chip 12. These posts are disposed on chip 12 before assem- 50 bly of layer 16. The solder mask 30 is laminated to the top side of the can walls and the top surface 18 of the chip carrier 14. As in other embodiments, the solder mask 30 might include a vent hole 38 to prevent air from becoming within the encapsulation area or within the elastomeric layer area. 55 A needle 32 is then inserted through aligned apertures in the chip carrier 14 and the solder mask 30, and the encapsulation material 40 is either injected into the gap between layer 16 and chip 12. As discussed in detail in the '882 application, the elastomeric material can convey itself through the gap 60 area by capillary action.

FIGS. 10A-10C illustrate the steps taken in accordance with yet another embodiment of the present invention. Generally, this embodiment relates to the use of a preform 48 of the encapsulation material In other words, the encapsulation material 40 can be arranged in or adjacent the encapsulation area in a non-liquid state, so that the encapsulation area in a non-liquid state, and the en

sulation material 40 can flow into or throughout the encapsulation area upon application of heat or any other expedient appropriate for a given encapsulation material. This concept can be employed in connection wish any other embodiment of the present invention, and is not limited to the specific steps shown in FIGS. 10A-10C.

In FIG. 10A and 10B, the preform 48 is provided around the inside of a can 42 which is to surround a chip assembly 10. The can 42 has an inverted L-shaped profile in this embodiment, but can take on any appropriate shape. A solder mask 30 is provided, and includes terminal holes 37 for registration with the terminals 26 of a chip assembly 10. The solder mask 30 is secured to the top side of the can 42, by vacuum lamination or any other method of attachment, either before or after association with the chip assembly 10. The structure in FIG. 10A is then married with a semiconductor chip assembly 10, the terminals 26 being pressed through the terminal holes 37. As shown in FIG. 10B, the preform 48 might be deformed somewhat by the peripheral portions of the chip assembly 10.

In FIG. 10C, the melting of the preform 48, and the flowing of the encapsulation material 40 is illustrated. As shown in FIG. 10C, a meniscus 50 is formed in the opening between the can 42 and the assembly 10, thus preventing the encapsulation material 40 from flowing out of the encapsulation area. It is noted that the encapsulation material 40 must be, in the illustrated embodiment, one which works by capillary action and exhibits sufficient surface tension to form the meniscus and prevent the further flow of the encapsulation material 40. On the other hand, the structure shown in FIG. 10B can be inverted and the preform can be subjected to heat, thus melting the preform 48, whereupon the encapsulation material 40 will fill the encapsulation area by gravity.

The melting of the preform 48 when the structure is in the inverted position lends itself to the use of a preform 48 of a specific volume that will fill the encapsulation area, but will not overflow out of the encapsulation area. Such a preform 48 is shown in FIG. 11 disposed in connection with a can 42 having an L-shaped profile. Unlike FIGS. 10A-110C, the structure in FIG. 11 does not show the use of a solder mask or other physical barrier to protect the terminals 26. Rather, the preform 48 is of such a volume that it will fill only the encapsulation area. Of course, both measures of protecting the terminals 26 can be employed (i.e., a physical barrier and a preform of predetermined volume). Thus, the encapsulation area must be calculated, and an appropriately sized preform must be provided. The preform can be a bead of encapsulation material formed by extrusion or injection molding or any other means. It must, however, be relatively uniform in size so that an appropriate amount of encapsulation material flows in every area about the periphery of the chip assembly 10, yet does not overfill the encapsulation area at any point.

The heating of the preform in any of the previously discussed embodiments can be accomplished heating the lower surface of the chip 12 in a vacuum oven. In order to control the flow of the encapsulation material and prevent damage to the chip carrier 14, the top of the assembly might be cooled to reduce radiant heat.

In FIG. 12, a semiconductor chip assembly 10 is shown on a support surface 54, and surrounded by a ring 42. As the ring is not high enough to be flush with the top surface of the chip carrier 14, a spacer 52 is provided about the periphery of the chip assembly 10 and under the ring 42.

A further embodiment is shown in FIG. 13, revealing that the present invention contemplates arrangements which differ from the arrangement set forth above. Specifically, in FIG. 13, the semiconductor chip 12 is surrounded by a chip carrier 14, which is preferably formed by a top layer 16 and an elastomeric pad 20. In this case, the chip carrier 14 surrounds the semiconductor chip 12, and the leads 22 from 5 the chip carrier 14 are directed inwardly and are connected to the semiconductor chip 12 via contacts 24. As with previous embodiments, this assembly can be encapsulated as shown in any of the previous embodiments. In FIG. 13. this assembly is positioned with a can 28 for encapsulation. Although any of the previously-described methods might be suitable for encapsulating the assembly in FIG. 13, the use of the solder mask 30 over the terminals or bumps 26 is illustrated. The solder mask 30 includes a fill hole 36 for purposes of inserting the encapsulation material, as well as a vent, hole 38.

The present invention can be applied in encapsulating any structure, whether the leads fan in, fan out or both. Any of the structure and arrangements illustrated and described in commonly assigned U.S. Pat. No. 5,148,265, the disclosure incorporated herein by reference, can be encapsulated in 20 accordance with the present invention.

While the foregoing description and figures illustrate some preferred embodiments of the method in accordance with the present invention, it should be appreciated that certain, modifications may be made and are encouraged to 25 be made in the steps, structure, arrangement and materials of the disclosed embodiments, particularly as may be applicable from the disclosure incorporated herein by reference, without departing from the spirit and scope of the present invention which is defined by the claims which are set forth 30 immediately hereafter.

We claim:

- 1. A method of encapsulating a semiconductor chip assembly having a top layer with an array of exposed terminals thereon, the terminals being electrically connected 35 to the chip, said method comprising the steps of:
 - placing an encapsulant barrier adjacent the semiconductor chip assembly, said encapsulant barrier at least partially defining an encapsulation area;
 - providing a protective barrier in contact with said top 40 layer for protecting the terminals on the top layer from an encapsulation material; and
 - introducing an encapsulation material into at least a portion of the encapsulation area so that the encapsulation material flows to fill the encapsulation area and 45 then cures to a substantially solid condition, the protective barrier preventing the encapsulation material from contacting the terminals on the top layer.
- 2. The method in claim 1, wherein said encapsulation material is a curable material which is in liquid form when 50 introduced into said encapsulation area.
- 3. The method in claim 2, further comprising the step of curing said curable material after said curable material has been introduced into said encapsulation area.
- heating said curable material.
- 5. The method in claim 3, wherein the step of curing includes mixing a plurality of mutually reactive material to form said curable materials during or before said curable material is introduced into said encapsulation area, whereby 60 said curable material is at least partially cured by reaction of said mutually reactive materials.
- 6. The method in claim 3, wherein said curable material is a curable elastomer.
- 7. The method in claim 1, wherein said introducing step 65 includes step of introducing a preform into said encapsula-

- 8. The method in claim 7, wherein said introducing step includes heating said preform so that it liquefies and said encapsulation material flows substantially throughout the encapsulation area.
- 9. The method in claim 1, wherein said placing step includes placing said encapsulant barrier a spaced distance from the periphery of said semiconductor chip.
- 10. The method in claim 1, wherein said encapsulant barrier in said placing step is at least a portion of a mold, and further comprising the step of removing the mold after the encapsulation material is at least partially cured.
- 11. The method in claim 1, wherein said encapsulant barrier in said placing step is at least a portion of a can which forms part of a package for the chip assembly, said can being 15 secured to said chip subassembly.
 - 12. The method in claim 11, wherein said can includes a bottom in contact with the semiconductor chip and a wall extending upwardly from said bottom about the periphery of said semiconductor chip.
 - 13. The method in claim 12, wherein said can, is made from aluminum or an aluminum alloy.
 - 14. The method in claim 12, further comprising the step of positioning said semiconductor chip assembly within said can via positioning means in said can.
 - 15. The method in claim 14, wherein said step of positioning includes centering said semiconductor chip assembly via said positioning means.
 - 16. The method in claim 1, wherein said encapsulant barrier in said placing step is at least a portion of a ring which forms part of a package for the chip, said ring having a wall extending upwardly alongside said semiconductor chip assembly.
 - 17. The method in claim 1, wherein the introducing step is done before the placing step and includes associating a preform of an encapsulation material with the protecting
 - 18. The method in claim 17, wherein the providing step is done before the placing step.
 - 19. The method in claim 18, wherein said encapsulant barrier is a ring.
 - 20. The method in claim 1, wherein said top layer includes a top surface on which the array of terminals is disposed, and said barrier includes a dam extending upwardly from said top surface.
 - 21. The method in claim 20, wherein said providing step includes attaching said dam to said top surface.
 - 22. The method in claim 1, wherein said top layer includes a top surface on which the array of terminals are disposed, said protective barrier includes a sheet like mask, and said providing step includes attaching said mask to said top surface of said top layer and to said encapsulant barrier such that said mask extends over said encapsulation area.
- 23. The method as claimed in claim 22, wherein said encapsulant barrier includes a top edge substantially encir-4. The method in claim 3, wherein the curing step includes 55 cling said subassembly and said mask extends from said top surface of said top layer to said top edge of said encapsulant
 - 24. The method in claim 22, wherein said sheet like mask includes at least one opening in which the array of terminals are exposed.
 - 25. The method in claim 22, wherein said sheet like mask includes an array of terminal openings corresponding to said array of terminals on said top layer, and wherein said providing step includes aligning said array of terminal openings with said array of terminals prior to attaching said mask to said top surface so that said terminals are exposed above said mask.

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RICHARD M. WEKING Clerk, U.S. DESIGNOT COURT M.D. CHARLEME

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Attorneys for Plaintiff, Powertech Technology Inc.

ogy Inc

UNITED STATES DISTRICT COURT
NORTHERN DISTRICT OF CALIFORNIA

POWERTECH TECHNOLOGY INC.

Plaintiff,

v. TESSERA, INC.

Defendant.

1case No: 0 0 9 4 5

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COMPLAINT FOR DECLARATORY JUDGMENT

JURY TRIAL DEMANDED

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COMPLAINT FOR DECLARATORY JUDGMENT CASE NO.

- 26. The method in claim 25, wherein each of said array of terminal holes is sized such that said terminals fit closely in said terminal holes.
- 27. The method in claim 26, wherein said mask is a dielectric.
- 28. The method in claim 27, wherein said mask is an epoxy acrylic.
- 29. The method in claim 22, wherein the providing step includes vacuum lamination of said mask to said top surface of said top layer and said encapsulant barriers.
- 30. The method in claim 29, wherein said mask includes a fill hole communicating with said encapsulation area, and wherein said introducing step includes introduction of said encapsulant material via said fill hole.
- 31. The method in claim 30, wherein said mask includes 15 a vent hole communicating with said encapsulation area so that air does not become trapped in said encapsulation area during said introducing step.
- 32. The method in claim 22, wherein said encapsulant barrier includes a fill hole, and said introducing step includes 20 introduction of said encapsulation material via said fill hole.
- 33. The method in claim 1, wherein said top layer is a spaced distance above said semiconductor chip, and further comprising the step of supporting said top layer above said semiconductor at least during said providing step.
- 34. The method in claim 33, wherein said step of supporting said top layer includes providing a compliant layer between said top layer and said chip.
- 35. The method in claim 1, wherein said protective barrier is a cap which engages by said top layer and covers said 30 terminals.
 - 36. The method in claim 35, wherein said cap is metal.
- 37. The method in claim 35, wherein said cap is plastic.
- 38. The method in claim 35, wherein said cap is flexible and is forced against said top layer to prevent encapsulation 35 material from contacting said terminals.
- 39. The method in claim 1, wherein said encapsulant barrier is a ring having a top side, and further comprising the step of supporting said semiconductor chip assembly on a support surface and spacing said ring from said support 40 package for the chip. Surface such that the top side of said ring is at approximately the same height as the top surface of said top layer.

- 40. The method in claim 39, wherein said spacing step includes the positioning of a spacer on said support surface adjacent said semiconductor chip assembly.
- 41. A method of encapsulating a semiconductor chip assembly having a top layer with an array of exposed terminals electrically connected to the chip, said method comprising the steps of:
 - placing an encapsulant barrier adjacent the semiconductor chip assembly, said encapsulant barrier at least partially defining an encapsulation area;
 - disposing a preform made of an encapsulation material in said encapsulation area, said preform normally being in a substantially solid state and being meltable to a temporary liquid state, said preform being of a predetermined volume which is equal to or less than the volume of said encapsulation area; and
 - liquifying said preform so that said encapsulation material flows substantially throughout said encapsulation area, but does not flow out of said encapsulation area, at least in the area of the exposed terminals.
- 42. The method in claim 41, wherein said encapsulation material is curable, and further comprising the step of hardening said encapsulation material after said encapsulation material has flowed substantially throughout said encapsulation area.
- 43. The method in claim 42, wherein the liquifying step includes heating said preform, and said hardening step includes cooling said encapsulation material or allowing said encapsulation material to cool to the ambient temperature.
- 44. The method in claim 41, wherein said preform is an extruded or injection molded bead of said encapsulation material.
- 45. The method in claim 41, wherein said placing step includes placing said encapsulant barrier a space distance from the periphery of said semiconductor chip.
- 46. The method in claim 41, wherein said encapsulant barrier is at least a portion of a can which forms part of a package for the chip.
- 47. The method in claim 41, wherein said encapsulant barrier is at least a portion of a ring which forms part of a package for the chip.

UNITED STATES PATENT AND TRADEMARK OFFICE CERTIFICATE OF CORRECTION

PATENT ND. :

5,663,106

Page 1 of 2

DATED

September 2, 1997

INVENTOR(S) :

Karavakis et al.

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Column 1, line 60, change "materials" to read -- material --.

Column 5, line 22, after the word "assembly" delete "of".

Column 7, line 65, after the word "material" insert --40.--

Column 8, line 4, change "wish" to read -- with --.

Column 8, line 56, after the word "accomplished" insert -- by --.

Column 9, line 15, after the word "vent" delete the comma.

column 9, line 20, before the word "incorporated" insert
-- of which is --.

Column 9, line 25 after the word "certain" delete the comma.

Column 10, line 20, after the word "can" delete the comma.

Column 10, line 49, change "sheet like" to read -- sheetlike --.

UNITED STATES PATENT AND TRADEMARK OFFICE CERTIFICATE OF CORRECTION

PATENT NO. :

5,663,106

Page 2 of 2

DATED : INVENTOR(S) : September 2, 1997 Karavakis et al.

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Column 10, line 58, change "sheet like" to read -- sheetlike --.
Column 10, line 61, change "sheet like" to read -- sheetlike --.

Signed and Sealed this Tenth Day of February, 1998

Attest:

BRUCE LEHMAN

Attesting Officer

Commissioner of Patents and Trademarks

 Plaintiff Powertech Technology Inc. ("PTI") for its Complaint against Tessera, Inc. herein alleges:

NATURE OF ACTION

1. This is an action for declaratory relief brought by plaintiff PTI against defendant Tessera, Inc. ("Tessera") arising under the Patent Act of the United States, 35 U.S.C. §§ 100 et. seq., regarding non-infringement and invalidity of United States Patent No. 5,663,106 ("the '106 Patent"). A copy of the '106 Patent is attached hereto as Exhibit A.

PARTIES

- PTI is a corporation organized under the laws of Taiwan, Republic of China, and has a principal place of business at No. 26, Datong Rd., Hsinchu Industrial Park, Hukou, Hsinchu 303, Taiwan
- Upon information and belief, Tessera is a Delaware corporation with its principal place of business at 3025 Orchard Parkway, San Jose, California 95134.

JURISDICTION AND VENUE

- 4. PTI brings this civil action under the Patent Laws, Title 35 of the United States Code, and under the Declaratory Judgment Act, 28 U.S.C. § 2201 to obtain a declaration of no infringement and invalidity of the '106 Patent, which Tessera has asserted against PTI products marketed, sold, and imported into the United States by PTI's customers. Because this action arises under the Patent Laws of the United States, this Court has subject matter jurisdiction pursuant to 28 U.S.C. §§ 1331 and 1338(a). Further, because this action presents an actual controversy with respect to the validity and/or infringement of the patent in suit, the Court may grant the declaratory relief sought pursuant to 28 U.S.C. §§ 2201 and 2202.
- 5. On information and belief, the matter in controversy between PTI, a foreign corporation and Tessera, a Delaware corporation, exceeds the sum of \$75,000, exclusive of interest and costs. This Court has diversity jurisdiction under 28 U.S.C. § 1332.
- 6. Venue properly lies in this District pursuant to 28 U.S.C. §§ 1391(b), 1391(c), and 1400(b). Personal jurisdiction and venue over Tessera are proper in this District as Tessera markets and licenses its patent portfolio within this jurisdiction, and has its principal place of

business in this jurisdiction.

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FACTUAL BACKGROUND

- 7. PTI is a subcontract-packager of semiconductor chips. PTI obtains semiconductor chips from a chip manufacturer, packages them, and then returns the packaged chips back the manufacturer. Such PTI customers then market, sell, and import PTI-packaged products worldwide, including marketing, selling and importing into the United States. PTI packages chips in several different formats, including small-format "face-down" packages such as regular and stacked window-BGA formats ("wBGA") and mold-type micro-BGA ("uBGA") formats, "faceup" packages, and "exposed-chip" packages.
- 8. On or about October 20, 2003, PTI and Tessera entered into a patent license agreement entitled "Tessera, Inc. TCC® License Agreement" ("License Agreement"). The License Agreement includes the '106 Patent.
- 9. PTI has complied with its obligations under the License Agreement, including its obligation to pay royalties to Tessera and provide royalty reports for all packaged chips covered by the licensed patents.
- On December 7, 2007, Tessera initiated an Investigation before the International 10. Trade Commission ("ITC" or "Commission") entitled In the Matter of Certain Semiconductor Chips with Minimized Chip Package Size and Products Containing Same (III), ITC Inv. No. 337-TA-630 ("the 630 Investigation"), naming as Respondents certain PTI customers, as well as many customers of PTI's customers. In the Investigation, Tessera asserted several patents licensed under the License Agreement, including the '106 Patent, and alleged infringement via the importation and sale of wBGA and uBGA products, including those products packaged by PTI for the customers named as Respondents in the Investigation. Although PTI was not named as a respondent in this investigation, certain of its customers for packaged uBGA and wBGA chips were named as respondents.
- On the same day Tessera filed its complaint at the ITC, Tessera filed a concurrent action in the U.S. District Court for the Eastern District of Texas, Civil Action No. 2:07-cv-534, asserting the same patents and naming the same defendants as in the ITC action. In an order

dated February 25, 2008, the district court suit is stayed pursuant to 28 U.S.C. § 1659, pending the outcome of the 630 Investigation.

- 12. On August 28, 2009, the Administrative Law Judge ("ALJ") presiding over the 630 Investigation issued an Initial Determination, finding that the accused wBGA and uBGA products did not infringe the '106 Patent or the two other patents asserted by Tessera. The ALJ also found that the Respondents had not proven any of the asserted patents were invalid. Tessera and the Respondents petitioned the ITC for review of several of the ALJ's findings.
- December 29, 2009, issued its Final Determination. Among other things, the Commission determined that (a) the accused wBGA products did not infringe any of the asserted patents, including the '106 patent, (b) the accused uBGA products did not infringe the other asserted patents, and (c) the uBGA products met all the limitations of the asserted claims of the '106 Patent, but nevertheless there was no infringement of the '106 Patent under the doctrine of patent exhaustion. On January 28, 2010, Tessera filed a Notice of Appeal of the ITC decision with the U.S. Court of Appeals for the Federal Circuit. That appeal is pending.
- 14. On February 23, 2010, PTI paid to Tessera the royalties owed and due for products sold during the fourth quarter of 2009 pursuant to the License Agreement, except that PTI has informed Tessera that the royalties paid for wBGA products were paid "under protest" because, given the ITC decision, PTI does not believe that wBGA products are covered by any licensed Tessera patent, and therefore, that royalties are not owed on PTI's wBGA products.
- 15. By reason of the foregoing, there is a justiciable controversy between PTI and Tessera concerning non-infringement and invalidity of the '106 Patent.
- 16. PTI therefore seeks a Declaratory Judgment from this Court that PTI's wBGA packaging services have not and do not infringe Tessera's '106 Patent.
- 17. PTI also seeks a Declaratory Judgment from this Court that Tessera's '106 Patent is invalid.

FIRST CLAIM FOR RELIEF

DECLARATION OF NON-INFRINGEMENT OF THE '106 PATENT

- 18. PTI realleges and incorporates by reference, as if fully set forth herein, all of the allegations contained in paragraphs 1 through 17 of this complaint.
- 19. On information and belief, Tessera purports to be the owner by assignment of the '106 Patent, entitled "Method of Encapsulating Die and Chip Carrier," and issued September 2, 1997.
- 20. Through its institution and prosecution of the 630 Investigation and the currently-pending district court case, Tessera has indicated its belief that PTI's wBGA products infringe one or more claims of the '106 Patent.
- 21. Tessera has sued PTI's customers in both U.S. District Court and before the U.S. International Trade Commission for infringement of the '106 Patent with respect to wBGA products. PTI also has an objectively reasonable apprehension that Tessera will sue PTI or its customers for alleged infringement of the '106 Patent.
- 22. PTI's wBGA products have not and do not infringe, either directly or indirectly, contributorily or otherwise, any of the claims of the '106 Patent.
- 23. Accordingly, there exists an actual controversy between PTI and Tessera concerning whether the claims of the '106 Patent are not infringed by PTI.
- PTI seeks a declaration that PTI's wBGA products do not infringe the '106
 Patent.

SECOND CLAIM FOR RELIEF

DECLARATION OF INVALIDITY OF THE '106 PATENT

- 25. PTI realleges and incorporates by reference, as if fully set forth herein, all of the allegations contained in paragraphs 1 through 24 of this complaint.
- 26. Claims 1-4, 9, 10, and 33-35 of the '106 Patent are currently subject to a pending reexamination before the United States Patent Office. These claims of the '106 Patent are currently subject to a final rejection before the USPTO.
 - 27. Accordingly, there exists an actual controversy between PTI and Tessera

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1	concerning v	ether the claims of the	106 Patent are invalid.		
2	28. The claims of the '106 Patent are invalid under 35 U.S.C. §§ 102, 103, and/or				
3	112.				
4	29.	PTI seeks a declaration	that the '106 Patent is invalid.		
5		<u>PR</u>	AYER FOR RELIEF		
6	WHEREFORE, plaintiff PTI prays for relief as follows:				
7		A. For entry of judg	gment declaring the '106 Patent not infringed by PTI's		
8	wBGA products.				
9		B. For entry of judg	gment declaring the '106 Patent invalid.		
10		C. Declare this case	e exceptional under 35 U.S.C. § 285 and award PTI its		
11	11 costs, disbursements and attorneys fees in connection with this action; and				
12		D. Such other and f	further relief at the Court may deem just and proper.		
13		•	JURY DEMAND		
14	Plaintiff hereby requests a trial by jury on all issues triable by a jury.				
15	Datadi Mara	5 2010	EATEV & TADINIED TTD		
16	Dated: Marc), 2010	FOLEY & LARDNER LLP		
17			By: / lung /h		
18			GEORGE C. BEST GINA A. BIBBY		
19			Attorneys for Plaintiff Powertech Technology Inc.		
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United States Patent 1191

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Karavakis et al.

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Field of Search

[11] Patent Number:

5,663,106

[45] Date of Patent:

5,037,779

5,120,678

Sep. 2, 1997

[34]	CHIP CARRIER		
[75]	Inventors:	Konstantine Karavakis, Coram, N.Y.; Thomas H. Distefano, Monte Sereno, Calif.; John W. Smith, Jr., Austin, Tex.; Craig Mitchell, San Jose, Calif.	
[73]	Assignee:	Tessera, Inc., San Jose, Calif.	
[21]	Appl. No.:	246,113	
[22]	Filed:	May 19, 1994	
[52]	U.S. Cl		

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Primary Examiner—Richard D. Lovering
Attorney, Agent, or Firm—Lerner, David, Littenberg,
Krumholz & Mentlik

[57]

438/126; 438/127

...... 437/211, 224;

427/96; 29/841; 257/791

ABSTRACT

A method of packaging a semiconductor chip assembly includes the encapsulation of the same after establishing an encapsulation area and providing a physical barrier for protecting the terminals of a chip carrier. An alternative or supplement to providing a physical barrier is to provide a preform of an encapsulation material which includes a predetermined volume of such material so that only the encapsulation area is filled. For a semiconductor chip assembly which does not yet have an elastomeric layer, a method of simultaneously forming such an elastomeric layer and encapsulating a semiconductor chip assembly is also provided.

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47 Claims, 5 Drawing Sheets

